

Production and performance study of Diamond-Like Carbon for the resistive electrode in MPGD application

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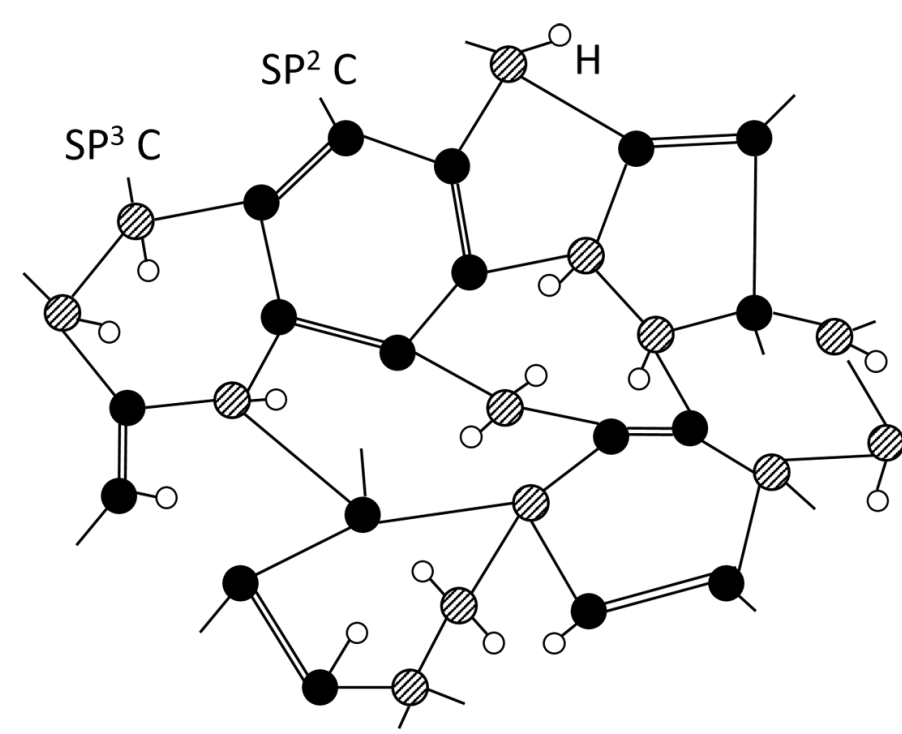


Diamond-Like Carbon (DLC) coatings provide a new method to produce high-quality resistive materials for MPGDs. Many studies on DLC production process of Magnetron Sputtering have been carried out to produce applicable DLC resistive materials for MPGDs. Two resistive electrodes with different structures (DLC/APICAL and Cu/DLC/APICAL) have been produced and tested in Micro-Resistive WELL detectors. THGEMs with DLC coating on dielectric surface to remove the charging-up effect was produced and tested. Application of DLC in Picosecond MicroMegas detector as a robust photocathode is also presented.

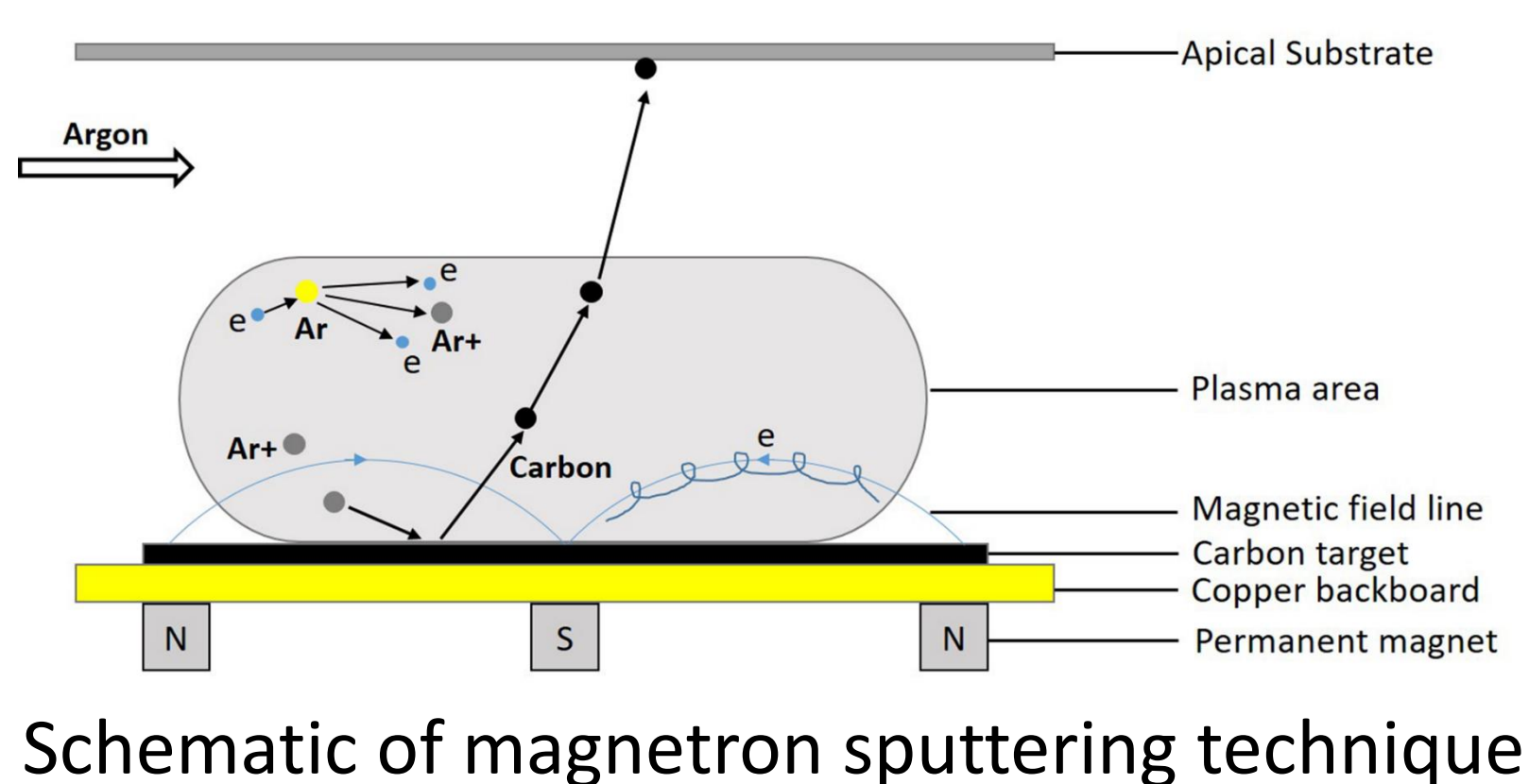
DLC & Magnetron Sputtering

Diamond-like Carbon (DLC): a class of metastable amorphous carbon material, first applied as resistive material in MPGDs by Atsuhiko Ochi [1].

Magnetron Sputtering: an effective way for DLC coating at low-temperature.



Atom structure of DLC



Schematic of magnetron sputtering technique

DLC coating:
Good adhesion & Stability

Magnetron Sputtering:
Accurate surface resistivity
Uniform thickness



Teer 650



Hauzer 850

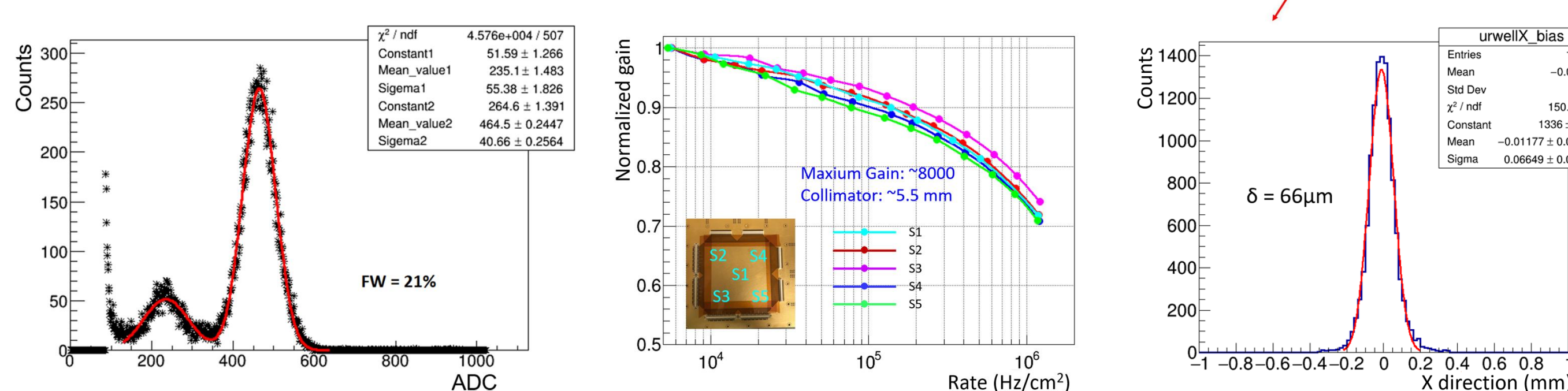
Application1: μ RWELL with 2-D readout

μ RWELL [2] prototype based on DLC-coated APICAL foil with 2-D readout

Energy resolution: $\sim 21\%$ @ 8 keV X-rays

Rate capability: gain drop $< 10\%$ @ 100kHz/cm²

Spatial resolution: $< 70 \mu\text{m}$ @ 150-GeV/c muons



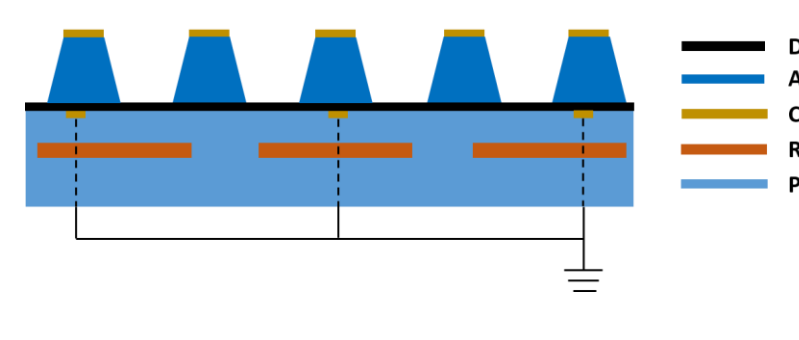
Special thanks to Rui De Oliveira and Antonio Teixeira for supplying the μ RWELL PCB

Application2: High-rate μ RWELL

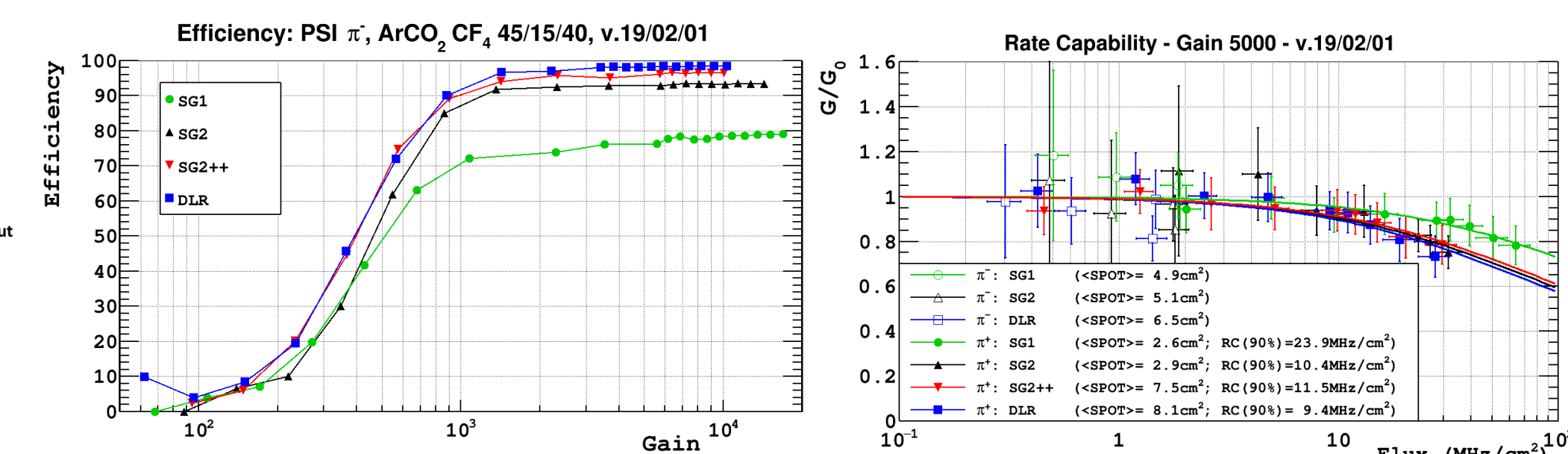
High-rate μ RWELL based on the combined structure of DLC resistive electrode

SILVER-GRID 2++ μ RWELL: The copper clad on the DLC is etched to dash strips and grounded at every a few mm.

High-rate μ RWELL PCB



- Efficiency: 97%
- Gain drop $< 10\%$ @ 5 MHz/cm²



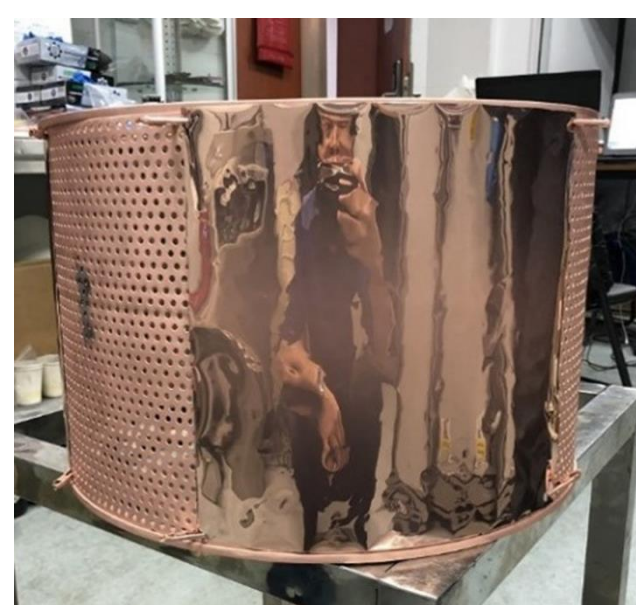
Courtesy of G. Bencivenni & DDG-LNF group

High space resolution μ RWELL for high-rate applications G.Bencivenni – Plenary session 19/2/2019

DLC samples



DLC/APICAL (Single & double side)

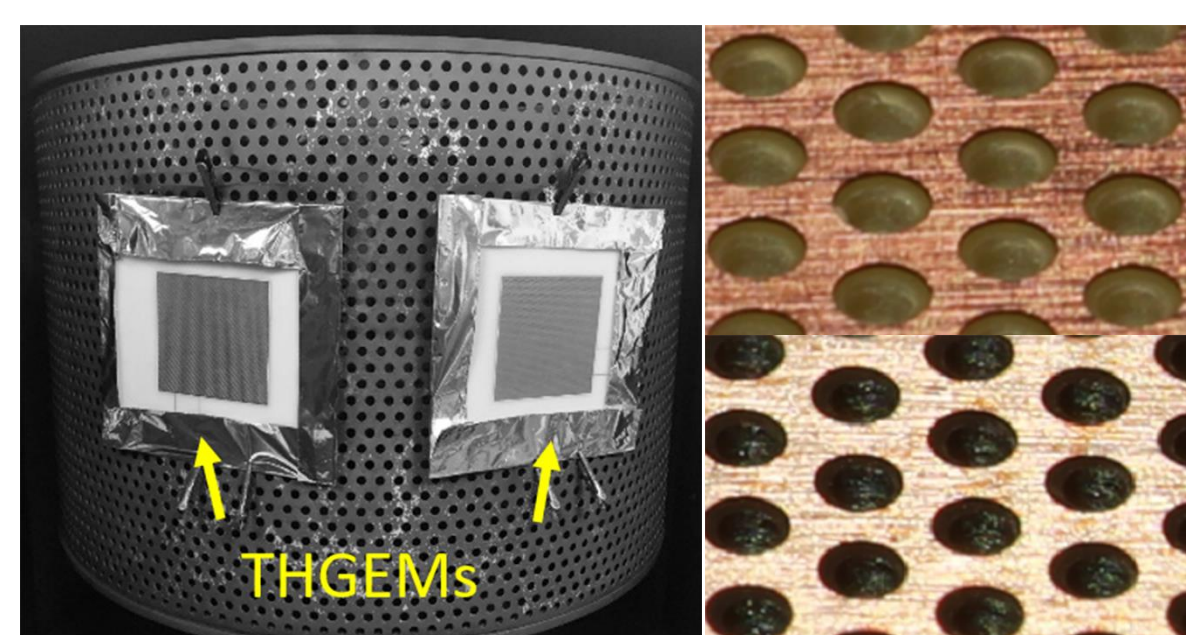


Cu/DLC/APICAL

Copper covered DLC:

- Chromium: $\sim 10 \text{ nm}$
- Copper: $\sim 4.3 \mu\text{m}$

Chromium is used to improve the adhesion between DLC and copper.



DLC-THGEM

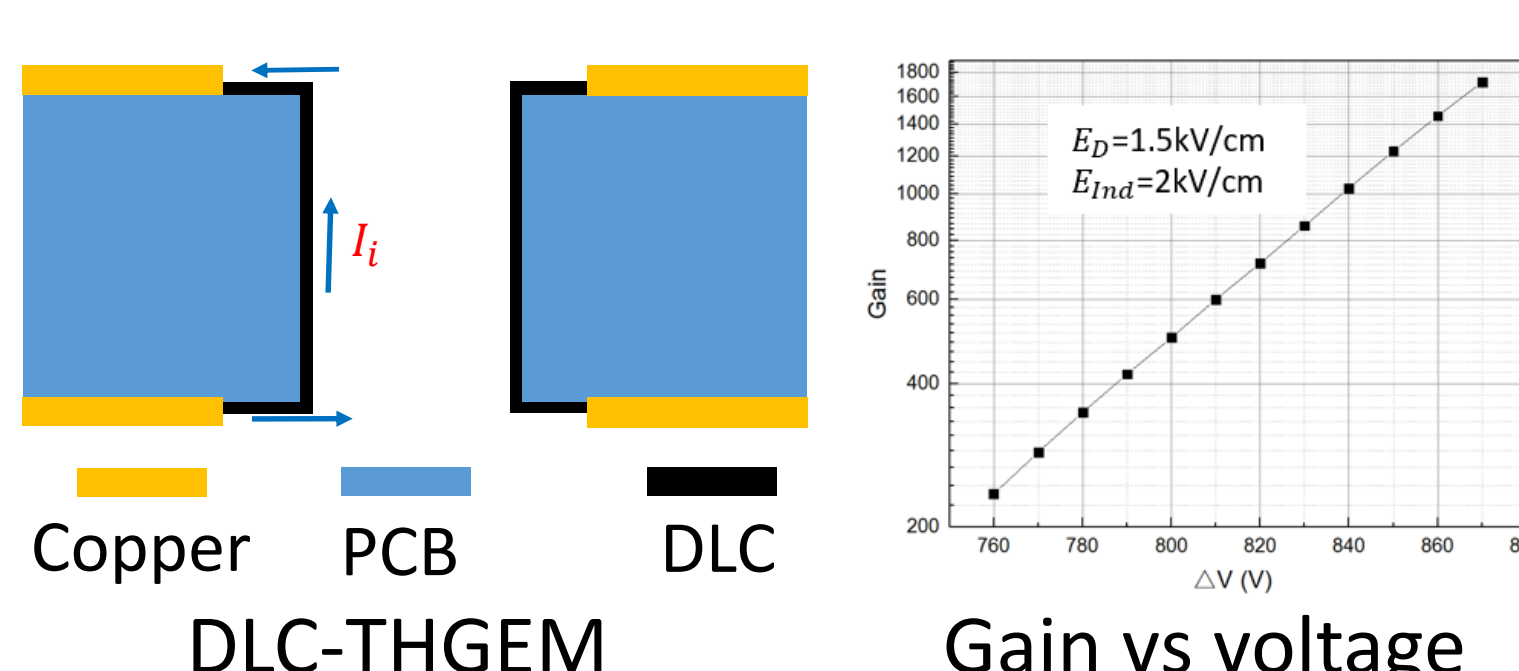


DLC for Radiation-hard photocathode
3 mm MgF₂ + DLC (different thickness)

Special thanks to LICP for technical support of the DLC coating

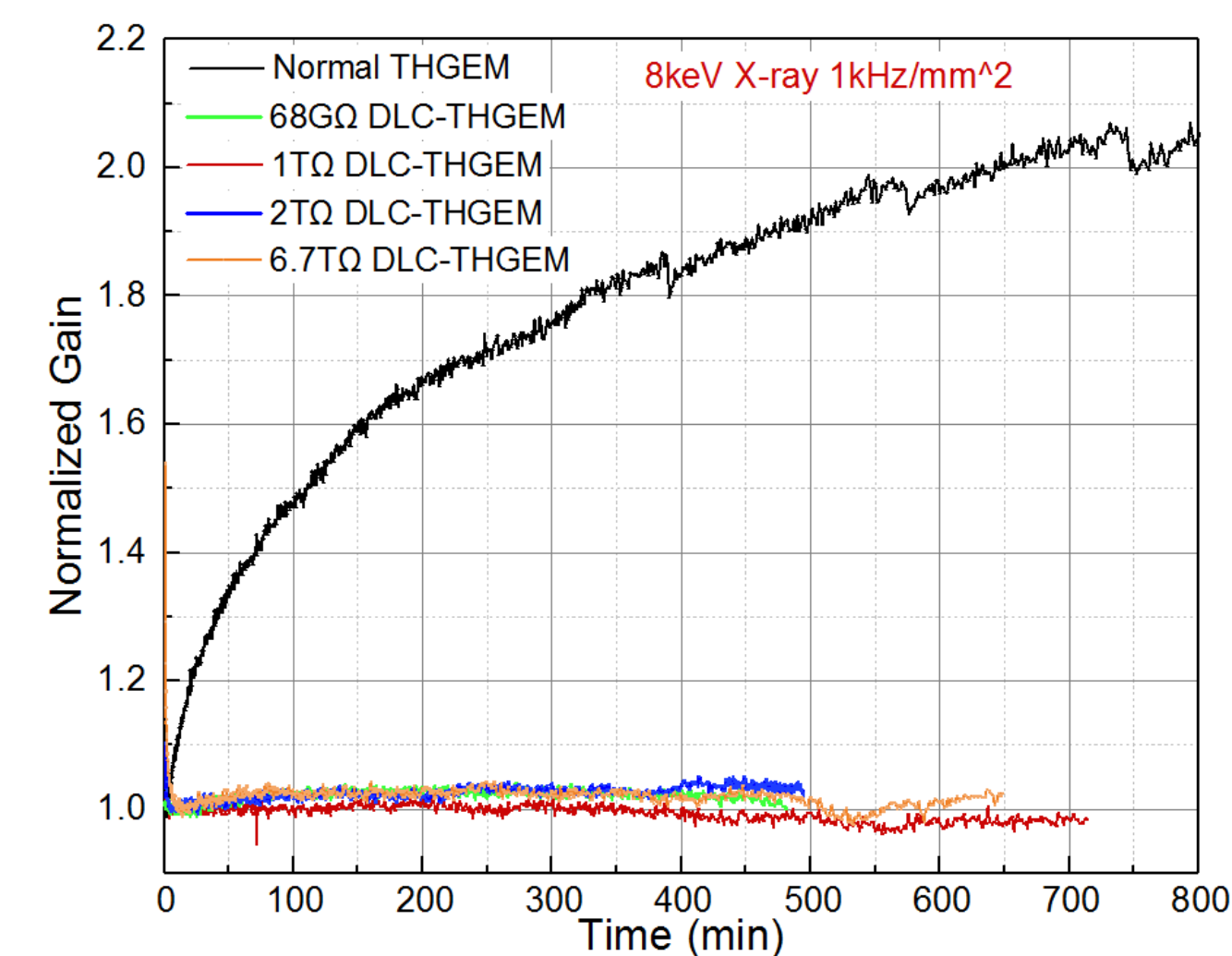
Application3: Charging-up free THGEM

DLC-THGEM: coating DLC on THGEM dielectric surface



The time evolution of gain of DLC-THGEM with different resistance were tested.

✓ Long term charging-up effect removed.



Characterization of DLC

Surface resistivity: M Ω -G Ω

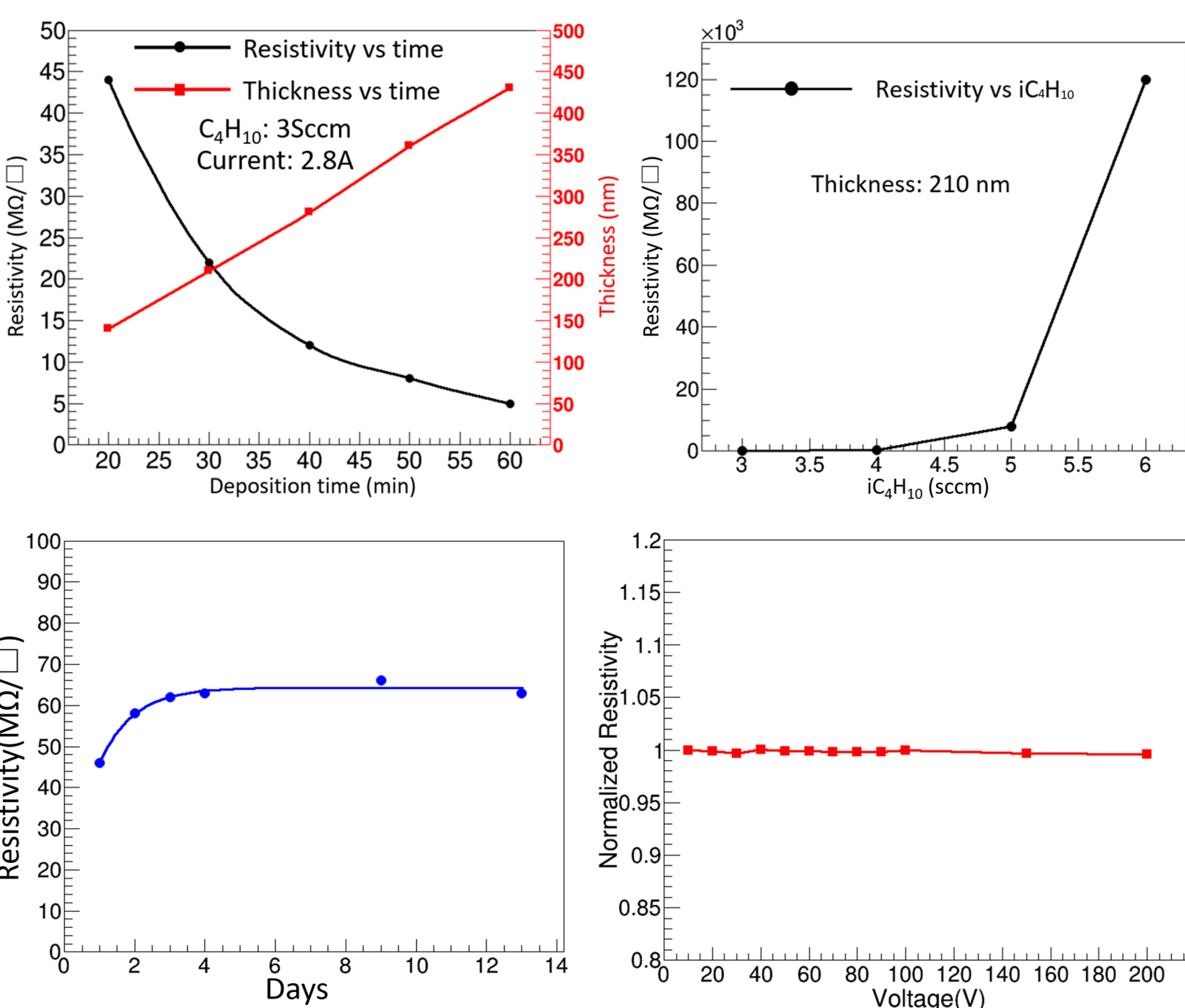
- Sensitive to iC₄H₁₀
- More precise by controlling the thickness

Uniformity:

- $\sim 15\%$ @ 15cm \times 15cm sample
- $\sim 23\%$ @ 25cm \times 25cm sample

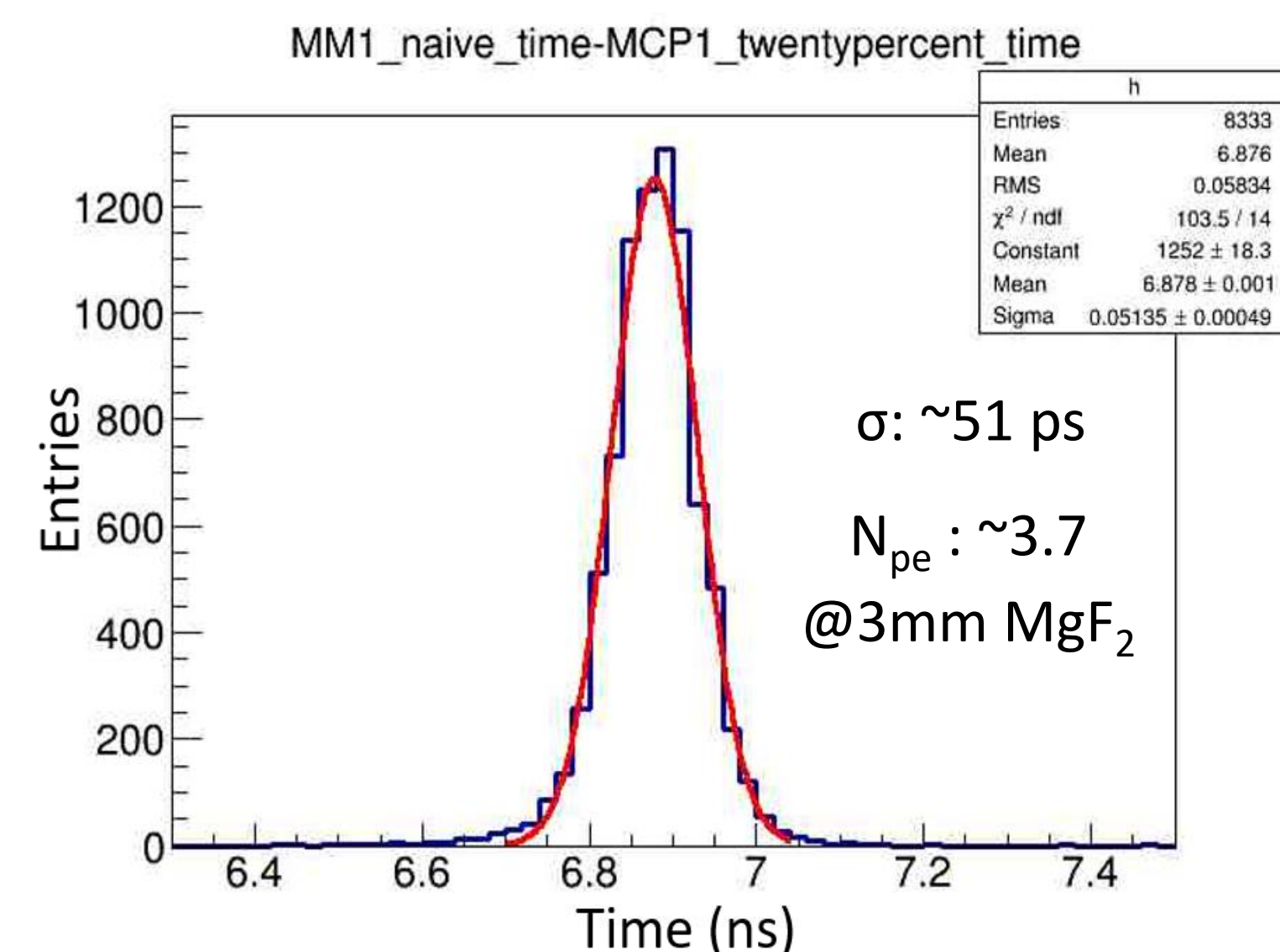
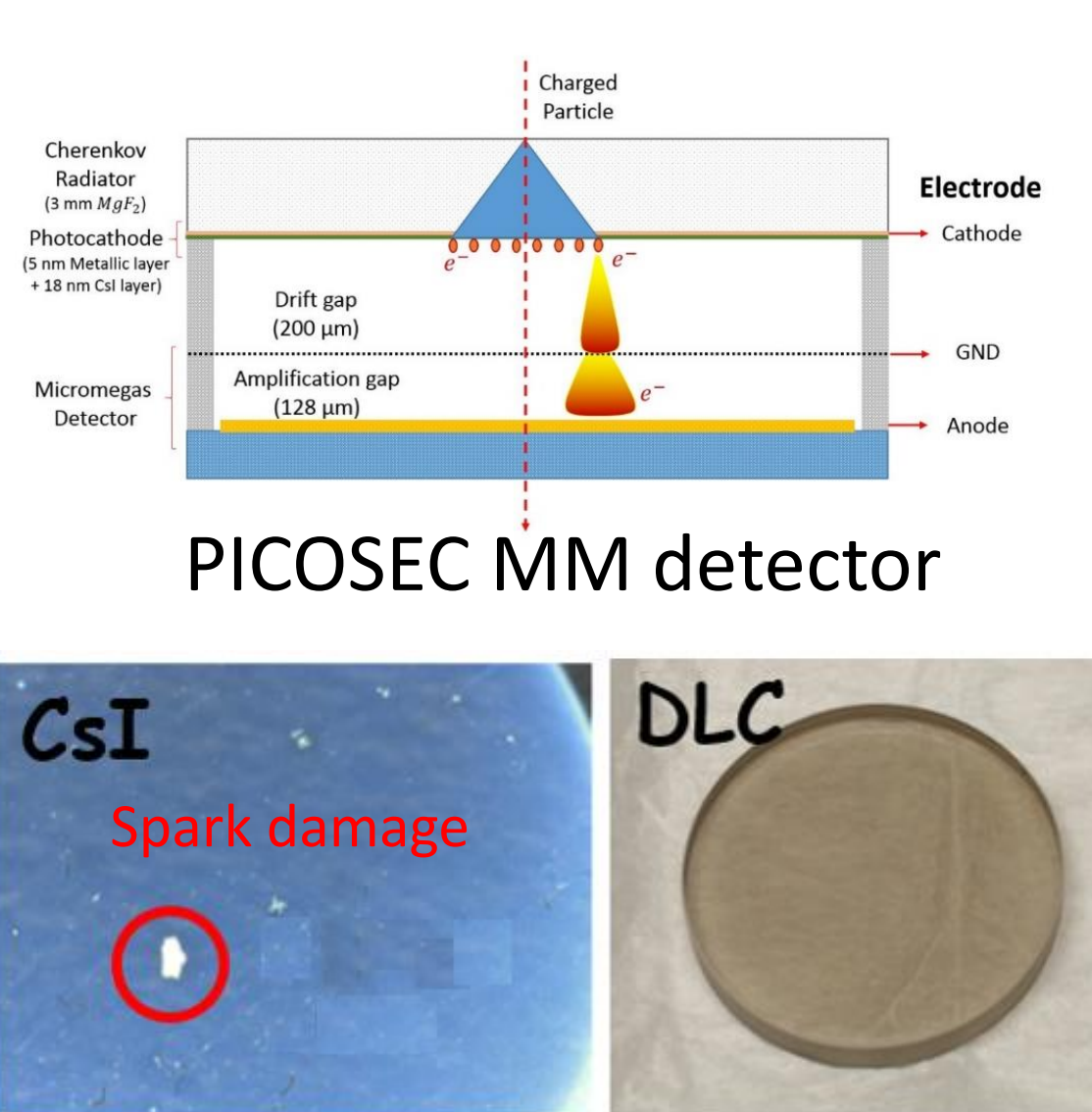
Stability:

- Increase 30% in the first 4 days and stayed stable.
- Independent with the voltage, showing ohmic behavior.



Application4: Radiation-hard photocathode

DLC: applied as the radiation-hard photocathode for PICOSEC MM [3] detector



Summary

1. Performance and production process of DLC, as high quality resistive materials, have been studied based on magnetron sputtering technique.
2. The characterization of a two-dimensional readout μ RWELL and high-rate μ RWELL based on DLC resistive electrode are performed.
3. The DLC-THGEM for charging-up free and DLC for radiation-hard photocathode in PICOSEC are presented too.

[1] Ochi A. Carbon sputtering technology for MPGD detectors[C]//Technology and Instrumentation in Particle Physics 2014. SISSA Medialab, 2015, 213: 351.

[2] G. Bencivenni et al. The micro-Resistive WELL detector: a compact spark-protected single amplification-stage MPGD. Journal of Instrumentation 10.02 (2015): P02008.

[3] J. Bortfeldt, et al. "PICOSEC: Charged particle timing at sub-25 picosecond precision with a Micromegas based detector", Nucl. Instru. Methd A, 903 317 2018